



PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael J. PELLIN, et al.
Serial No.: 10/799,181
Application: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE
SUPERCONDUCTORS MATERIAL SYNTHESIS
Art Unit: 2812
Filing Date: March 12, 2004
Atty. Docket: 0003/01288

CERTIFICATE OF MAILING: I hereby certify that this correspondence is being deposited per 37 C.F.R. 1.8 with the United States Postal service as first class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 3, 2006 (Date of Deposit)

Marilynn G. Oleck
Name of Representative

Marilynn G. Oleck
Signature

11/3/06
Date of Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

20 North Wacker Dr.
Chicago, IL 60606
312-621-1330

STATUS INQUIRY

Sir/Madam:

This is an official Status Inquiry request for the above-identified application.

More than 30 months has passed since the filing of this Patent Application on March 12, 2004. A return postcard stamped by the USPTO having serial number 10/799,181 has been received. Attorney check #.3600 in the amount of \$425.00 which accompanied the filing has been cashed.

Enclosed please find photocopies of the following: a June 1, 2004 filing receipt, USPTO stamped return postcard, the cashed check, and the Recordation of Assignment. No further communication has been received from the Patent and Trademark Office indicating action on this application.

Kindly advise the undersigned of the present status of this application.

Respectfully submitted,

Dated: November 3, 2006

Michael J. Cherskov
Michael J. Cherskov
Reg. No.: 33,664
Attorney for applicants



UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/799,181	03/12/2004	2812	385	0003/01288	7	20	2

CONFIRMATION NO. 8160

27197

CHERSKOV & FLAYNIK
THE CIVIC OPERA BUILDING
20 NORTH WACKER DRIVE, SUITE 1447
CHICAGO, IL 60606

FILING RECEIPT



OC000000012822344

Date Mailed: 06/01/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Michael J. Pellin, Naperville, IL;
John N. Hryn, Naperville, IL;
Jeffrey W. Elam, Downers Grove, IL;

Domestic Priority data as claimed by applicant

This appln claims benefit of 60/454,160 03/12/2003

Foreign Applications

If Required, Foreign Filing License Granted: 05/28/2004

Projected Publication Date: 09/16/2004

Non-Publication Request: No

Early Publication Request: No

** SMALL ENTITY **

Title

Atomic layer deposition for high temperature superconductor material synthesis

**LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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On the date stamped hereon, the United States Patent and Trademark Office acknowledges receipt of an application, drawings, Utility Transmittal, a recordation sheet, a fee transmittal, Assignment, a Declaration, a check, and a return-receipt postcard.

Re: Pellin et al.

Title: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE
SUPERCONDUCTOR MATERIAL SYNTHESIS

Atty. Dkt.: 0003/01288

The aforementioned was mailed on Friday, March 12, 2004 via
Express Mail #ER605288065US.



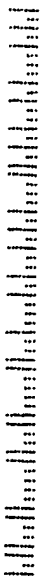
PTO DATE STAMP

22141 U.S. PTO
10/799181





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DATE March 12, 2004 2-50-710

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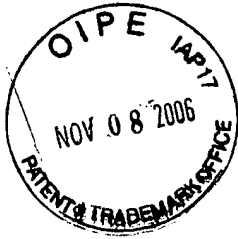
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FOR 3/01288 Pat. Appl. fee & Assignment

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UNITED STATES PATENT AND TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND
DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE

APRIL 25, 2005

PTAS



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UNITED STATES PATENT AND TRADEMARK OFFICE
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BRIEF: ASSIGNMENT OF ASSIGNOR'S INTEREST (SEE DOCUMENT FOR DETAILS).

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DOC DATE: 03/12/2004

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SERIAL NUMBER: 10799181
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ISSUE DATE:

TITLE: ATOMIC LAYER DEPOSITION FOR HIGH TEMPERATURE SUPERCONDUCTOR
MATERIAL SYNTHESIS

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015937/0487 PAGE 2



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